## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85096

Masamichi INENAGA, et al.

Appln. No.: 10/516,693

Group Art Unit: 2886

Confirmation No.: 6877

Examiner: Isiaka O. Akanbi

Filed: December 6, 2004

For:

WAFER PRE-ALIGNMENT APPARATUS AND METHOD

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of one month, extending the time for responding to the Office Action of January 16, 2007 to May 16, 2007.

The statutory fee of \$120.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is also directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: May 14, 2007

respectionly submitted

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